



AF1/2279

Amendment Under 37 C.F.R. § 1.116 Group Art Unit 2879, Expedited Procedure

In re Application of:

Docket No. 03500.014023.

TAMAKI KOBAYASHI ET AL.

Application No.: 09/440,535

Examiner: A. Patel

Filed: November 16, 1999

Group Art Unit: 2879

For:

SUBSTRATE FOR ELECTRON SOURCE,

ELECTRON SOURCE AND IMAGE FORMING APPARATUS, AND MANUFACTURING METHOD

THEREOF

Date: November 13, 2002

RECEIVED
NOV 21 2002
TECHNOLOGY CENTER 2800

THE COMMISSIONER FOR PATENTS

BOX AF

Washington, D.C. 20231

Sir:

Transmitted herewith is an amendment in the above-identified application.

No additional fee is required.

The fee has been calculated as shown below

CLAIMS AS AMENDED								
s	(2) CLAIMS REMAINING AFTER AMENDMENT		(4) HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	RATE	ADDITIONAL FEE		
TOTAL ÇLAIMS	* 184	MINUS	** 138	46	x \$9 \$18	828.00		
INDEP. CLAIMS	* 2	MINUS	***	0	x \$42 \$84	0		
Fee for Mu								
	828.00							

If the entry in Column 2 is less than the entry in Column 4, write "0" in Column 5.

If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in

this space.

*** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 3, write "3" in this space.

	°Verified Statement claiming small entity status is enclosed, if not filed previously.						
X	A check in the amount of \$\ 828.00 is enclosed.						
	Charge \$ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed.						
X	Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.						
	A check in the amount of \$ to cover the fee for a month extension is enclosed.						
	A check in the amount of \$ to cover the Information Disclosure Statement fee is enclosed.						
X	Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.						
	Respectfully submitted,						
	Attorney for Applicants						
	Attorney for Applicants						

Registration No. 42476

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200

NY_MAIN 306885v1



Amendment UnGer 37 C.F.R. § 1.116 Group Art Unit 2879, Expedited Procedure

03500.014023

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

	In re Application of:) d		
	TAMAKI KOBAYASHI ET AL.	:)	Examiner: A. Patel	
	Application No.: 09/440,535	:)	Group Art Unit: 2879	
	Filed: November 16, 1999	:)		
· rel s	For: SUBSTRATE FOR ELECTRON SOURCE, ELECTRON SOURCE AND IMAGE FORMING APPARA- TUS, AND MANUFACTURING) :)		
(My Jus)	METHOD THEREOF Commissioner For Patents BOX AF)	November 13, 2002	
1 1/2/2/	Washington, D.C. 20231			

AMENDMENT AFTER INAL REJECTION, REQUEST FOR CONSIDERATION OF PREVIOUSLY CITEDART, REQUEST FOR RECONSIDERATION OF IMPROPER FINALITY OF OFFICE ACTION, AND CONDITIONAL PETITION

Sir:

In response to the Office Action (Paper No. 13) of August 13, 2002, please

amend the above-identified application as follows, pursuant to 37 C.F.R. § 1.116:

11/20/2002 AWONDAF1 00000002 09440535 01 FC:1202

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231 on November 13, 2002.

(Date of Deposit)

FRANK A. DeLUCIA (Same of Attorney for Applicant)

November 13, 2002

Date of Signature

828.00 OP